
Cleanrooms and associated controlled environments —

**Part 17:
Particle deposition rate applications**

*Salles propres et environnements maîtrisés apparentés —
Partie 17: Applications de taux de dépôt de particules*





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ISO copyright office
CP 401 • Ch. de Blandonnet 8
CH-1214 Vernier, Geneva
Phone: +41 22 749 01 11
Email: copyright@iso.org
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